Docket No. 740819-548

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	Patent Application of:)	•
Mitsu	TANABE)	Group Art Unit: 2817
Serial	l No. 09/838,214)	Examiner: Benny T. Lee
Filed:	: April 20, 2001)	
For:	MICROSTRIP LINE, METHOD FOR FABRICATING THE SAME, INDUCTOR ELEMENT, AND RF SEMICONDUCTOR DEVICE)))	LING
	CERTIFICATE OF MAILING		

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner of Patents, Washington, D.C. 20231 on 3-27-03

Commissioner for Patents Washington, D.C. 20231

Sir:

AMENDMENT

Amissioner for Patents
Ington, D.C. 20231

In response to the Office Action dated December 3, 2002, please amend the didentified application as follows. above-identified application as follows.

IN THE DRAWINGS:

Attached hereto is a request for approval of Drawing Corrections with amended Figures 5C, 12D, 13B, and 14B.

IN THE SPECIFICATION:

Please amend the Specification as follows: